

## RECEIVED DEC 0 2 2003 TC 1700

**DOCKET NO: VSEA 28-00** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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OCT 17 2003

TC 1700

Applicant:

Steven R. Walther et al.

Serial No:

10/005,613

Confirmation No:

9731

Filed: For:

October 26, 2001

HYBRID SCANNING SYSTEM AND METHODS FOR ION

IMPLANTATION

Examiner:

Rodney Glen McDonald

Art Unit:

1753

## **CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the day of October, 2003.

Cheryl Purpell

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **Petition for Extension of Time**

A three-month extension of time to October 8, 2003 is requested for response to the Examiner's Office Action of April 8, 2003.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,

Steven R. Walther et al., Applicants

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By:

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